



Patent
Attorney's Docket No. 015290-500

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	
S. Y. LI et al.)	Group Art Unit: 1763
Application No.: 09/820,695)	Examiner: A. W. Olsen
Filed: March 30, 2001)	Confirmation No.: 4162
For: METHOD OF PLASMA ETCHING)	
LOW-K DIELECTRIC MATERIALS)	
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)	

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action mailed September 27, 2005, please amend
the above-identified patent application as follows:

12/08/2005 JADD01 00000019 09820695
01 FC:1202 50.00 0P